

<b>Notice of References Cited</b>	Application/Control No. 10/064,717	Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner Jonathan C. Schaffer	Art Unit 2621	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,259,108	07-2001	Antonelli et al.	250/556
	B	US-6,154,727	11-2000	Karp et al.	705/3
	C	US-4,544,267	10-1985	Schiller, Michael	356/71
	D	US-2,569,310	09-1951	HITT IVAN E	118/31.5
	E	US-2002/0140542	10-2002	Prokoski et al.	340/5.52
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.